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PATENT  
Attorney Docket No. 0553-0242.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: )  
Shunpei YAMAZAKI, et al. )  
Serial No.: 10/790,972 )  
Filed: March 2, 2004 )  
Examiner: Michael K. Luhrs )  
Art Unit: 2824 )  
For: THIN FILM FORMING DEVICE, METHOD )  
OF FORMING A THIN FILM, AND SELF- )  
LIGHT-EMITTING DEVICE )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:	
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on	
<u>September 28, 2005</u> (Date of Deposit)	
<u>Shannon Wallace</u> Name of applicant, assignee, or Registered Rep.	
<u>Shannon Wallace</u> Signature	<u>9/28/05</u> Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT C (AFTER FINAL)**

Dear Sirs:

In response to the Final Rejection of June 28, 2005, please amend the above-identified application as follows: